

Application Data Sheet

Application Information

Application Type:: Regular
Subject Matter:: Utility
Suggested classification::
Suggested Group Art Unit::
CD-ROM or CD-R?:: None
Computer Readable Form (CRF)?:: No
Title:: APPARATUS AND METHOD OF CLEANING
A SUBSTRATE
Attorney Docket Number:: 025311-0114
Request for Early Publication?:: No
Request for Non-Publication?:: No
Suggested Drawing Figure:: 1
Total Drawing Sheets:: 3
Small Entity?:: No
Petition included?:: No
Secrecy Order in Parent Appl.?:: No

A B C D E F G H I J K L M N O P Q R S T U V W X Y Z

Applicant Information

Applicant Authority Type:: Inventor
Primary Citizenship Country:: Japanese
Status:: Full Capacity
Given Name:: Satoshi
Family Name:: KUME
City of Residence:: Kanagawa

Country of Residence:: Japan
Street of mailing address:: c/o Semiconductor Leading Edge Technologies, Inc.
292 Yoshida-cho, Totsuka-ku
Yokohama, 244-0817, Kanagawa
Country of mailing address:: Japan

Correspondence Information

Correspondence Customer Number:: 22428

E-Mail address:: wellis@foleylaw.com

Representative Information

Representative Customer Number::	22428	

Domestic Priority Information

Application::	Continuity Type::	Parent Application::	Parent Filing Date::

Foreign Priority Information

Country::	Application number::	Filing Date::	Priority Claimed::
Japan	2001-016964	01/25/2001	Yes

Assignee Information

Assignee name::

SEMICONDUCTOR LEADING EDGE
TECHNOLOGIES, INC.